

Docket No.: 206276US2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Toshiaki WATANABE

: EXAMINER:

SERIAL NO. : 09/839,294

:

FILED: April 23, 2001

: GROUP ART UNIT:

FOR: EXPOSURE CONTROL
APPARATUS AND METHOD
THEREOF

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Please amend the above-identified patent application prior to action on the merits, as follows:

Please replace Figures 6 and 9 according to the attached Letter Requesting Approval of Substitute Drawings. The substitute drawings reflect the following changes:

1. Fig. 6, S607, line 2, change "PIXELS (Nn=NnR+1)" to "PIXELS (Nn=Nn+1)".
2. Fig. 6, S613, line 2, change "(Nn=Nn+En)" to "(Nn=Nn+Hn)".
3. Fig. 9, S908, line 2, change "PIXELS (Nn=NnR+1)" to "PIXELS (Nn=Nn+1)".

4. Please amend Fig. 9, S919, line 2, change “(Nn=Nn+En)” to “(Nn=Nn+Hn)”.

The noted changes in the figures are believed to correct for minor informalities, and no new matter is believed to have been added.



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Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Two handwritten signatures are placed here, one above the other.

Gregory J. Maier
Registration No. 25,599
Surinder Sachar
Registration No. 34,423
Attorneys of Record

(703) 413-3000 Phone

(703) 413-2220 Fax

GJM/SS/ALP:pch

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